

<b>Notice of References Cited</b>	Application/Control No. 10/783,751	Applicant(s)/Patent Under Reexamination LEVIN ET AL.	
	Examiner Duy-Vu N. Deo	Art Unit 1765	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-7,000,006	02-2006	Chen, Shigang	709/218
*	B	US-6,694,368	02-2004	An et al.	709/227
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	D	US-			
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	I	US-			
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**NON-PATENT DOCUMENTS**

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